



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Teemu SIPILA

SERIAL NO.: 10/010,429

FILING DATE: 12/3/01

TITLE: DATA PROCESSING METHOD

ATTORNEY DOCKET NO.: 324-010624-US (PAR)

EXAMINER:

ART UNIT:

Commissioner of Patents

Washington, D.C. 20231

RECEIVED
FEB 27 2002
Technology Center 2600

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

The following information is being disclosed to the Patent and Trademark Office as information that may be material to the examination of the above-identified patent application.

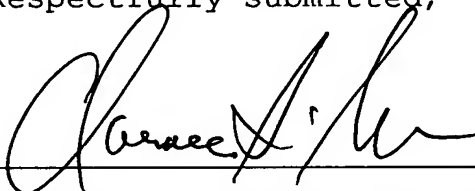
This Information Disclosure Statement is being filed within three months of the filing date of the above-identified patent application. Thus, a certification under 37 CFR 1.97 (e) or fee under 37 CFR 1.17(p) is not required for the information herein to be considered.

The above-identified patent application claims priority to Finnish Patent Application No. 20002692 filed on December 8, 2000. Applicant's attorney encloses a copy of a Finnish Office Action issued on the priority Finnish Patent Application No. 20002692. The Office Action cited United States Patent No. 5,687,198 and PCT International Publication No. WO 98/43360.

Copies of the Finnish Office Action and the cited references are enclosed together with PTO-Form 1449.

The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any over payment to Deposit Account No. 16-1350.

Respectfully submitted,



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6 Feb 02

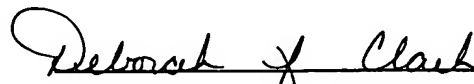
Date

CERTIFICATE OF MAILING

I hereby certify that the attached Supplemental Information Disclosure Statement, Finnish Office Action, PTO-Form 1449 and references are being deposited with the United States Postal Service as first class mail on the date shown below in an envelope addressed to: Commissioner of Patents, Washington, D.C. 20231.

FEB 6, 2002

Date



Name of Person Making Deposit

**INFORMATION DISCLOSURE
CITATION FORM FOR
PATENT APPLICATION
(FORM PTO-1449)
(Substitute)**

Docket No.: 324-010624-US(PAT)

Serial No.: 10/010,429

Applicant(s): Teemu SIPILÄ

Filing Date: 12/3/01

Group:

U.S. PATENTS

Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
	5,687,198	11/11/97	Sexton et al.	375	347	1/4/96

U.S. PATENT PUBLICATIONS

Initials	Publication No.	Pub. Date	Name	Class	Sub-class	Filing Date

FOREIGN PATENT DOCUMENTS

Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a
	WO 98/43360	10/1/98	PCT	Qualcomm Incorporated	n/a

OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.
Include a copy of this citation form with your next correspondence to the Applicant(s).

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